

Notice of References Cited

Application/Control No.

10/559,907

Applicant(s)/Patent Under
Reexamination
GUO ET AL.

Examiner

CHRISTINE CHEN

Art Unit

4116

Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,429,725	07-1995	Thorpe et al.	205/631
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.